



**ELECTRONIC COPY**

LG647466976  
Report verification at igi.org



August 13, 2024

IGI Report Number **LG647466976**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.15 - 8.17 X 4.88 MM**

**GRADING RESULTS**

Carat Weight **2.00 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

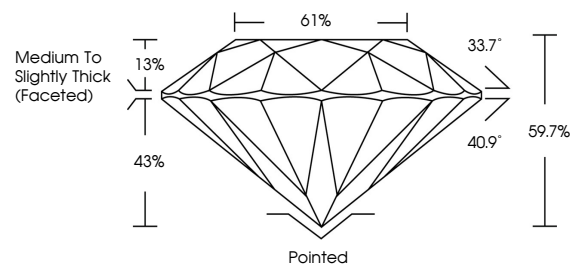
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG647466976**

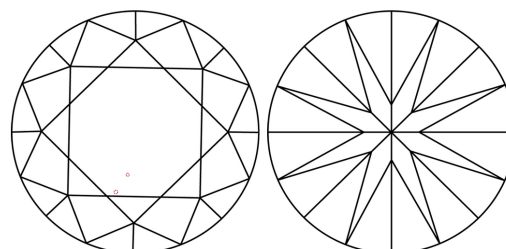
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

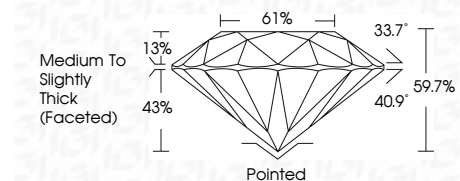
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



August 13, 2024	IGI Report No LG647466976	2.00 CARATS	E	VVS 2	EXCELLENT	61%	33.7°	40.9°	59.7%	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG647466976
ROUND BRILLIANT	8.15 - 8.17 X 4.88 MM	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Medium To Slightly Thick (Faceted)	Culet	Polish	Symmetry	Fluorescence	Inscription(s)

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